

Form PTO-1449

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)

TSMC-99-651

Application Number

09/531,403

Applicant

Ma-Chi Chiang et al.

Filing Date

03/20/00

Group/Art Unit

2823

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
LP	5994175	11/30/99	Gardner et al.	438	199	9/5/97
LP	5972783	10/26/99	Arai et al.	438	513	2/6/97
LP	5885877	3/23/99	Gardner et al.	438	300	4/21/97
LP	5920782	7/6/99	Shih et al.	438	303	12/12/97

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JUN 16 2000  
TECHNOLOGY CENTER 2800

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

Long Pham

DATE CONSIDERED

02/26/01

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.